

**TRANSMITTAL OF FORMAL DRAWINGS**Docket No.  
**OKI.313**In Re Application Of: **Noriyuki Miura**

Application No.	Filing Date	Confirmation No.	Examiner	Customer No.	Group Art Unit
10/092,499	03/08/200	1269	Le, Dung Anh	20987	2818

Invention: **METHOD OF MANUFACTURING A SILICON-ON-INSULATOR (SOI) SEMICONDUCTOR DEVICE**

Address to:  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Transmitted herewith are:

16 sheets of formal drawing(s) for this application.

☒ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).*Signature***ADAM C. VOLENTINE  
REG. NO. 33289****VOLENTINE FRANCOS, PLLC  
ONE FREEDOM SQUARE  
11951 FREEDOM DRIVE, SUITE 1260  
RESTON VA 20191**Dated: **AUGUST 9, 2004**

I certify that this document and attached formal drawings are being deposited on \_\_\_\_\_ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Signature of Person Mailing Correspondence**Typed or Printed Name of Person Mailing Correspondence*